PATENT APPLICATION



In re the Application of

Sadayoshi HORII et al.

Application No.: 10/529,466

Filed: May 2, 2005

Docket No.: 123373

For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE AND SUBSTRATE

PROCESSING APPARATUS

PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Specification;

Remarks.